

EQUIVDOC INC 'J62235738'

***** Item Number 1 of 1 *****

DESCRIP :: PATENT
TITLE :: Forming insulation film on semiconductor substrate - includes
 coating mixt. of silane condensn. cpd. and hydrophilic organic
 solvent, heat-curing, forming resist mask, and etching film
ASSIGNEE :: MATSUSHITA ELEC IND KK; JAPAN SYNTHETIC RUBBER
PACODE :: MATU ; JAPS
ACCNNO :: 194734
DATE :: Oct 15, 1987
COPYRIGHT :: FOR INTERNAL USE ONLY - PORTIONS COPYRIGHT BY DERWENT
 INFORMATION LIMITED - 1987
PNBASIC :: J62235738
PRIORNO :: J08679747
DATEPR :: Apr 07, 1986
EQUIVDOC :: J62235738 J08679747 JPAT
SUBJECTP :: Cure
LANG :: JAPANESE
TYPE :: PTNT
IPCODE :: H01L-021/31
DPCODE :: A85; L03; U11; R46
MANUAL :: A06-A00E2; A11-C02C; A12-E04; A12-E07C; L04-C12; U11-C05B5;
 U11-C05D2
YEAR :: 1987
YEARPR :: 1986
COMMENT :: 87-330806/47 < XRAM> C87-141179 < XRPX> N87-2473
RDATEMD :: Sep 22, 1999
RDATENT :: Mar 16, 1988
SECCODE :: 0
UPDATER :: TDD